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APPLICANTS

Kenneth S. Collins, San Jose, CA;
 Hiroji Hanawa, Sunnyvale, CA;
 Kartik Ramaswamy, Santa Clara, CA; Andrew Nguyen, San Jose, CA;
 Amir Al-Bayati, San Jose, CA;
 Biagio Gallo, Los Gatos, CA;
 Gonzalo Antonio Monroy, San Francisco, CA;

** CONTINUING DATA *****
 This application is a CIP of 10/164,327 06/05/2002 *of*

** FOREIGN APPLICATIONS *****
none, of

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
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Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY CA	SHEETS DRAWING 85	TOTAL CLAIMS 87	INDEPENDENT CLAIMS 1
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after (Alliance)	Verified and Acknowledged	Examiner's Signature <i>(Signature)</i>	Initials <i>(Initials)</i>	

ADDRESS
 Patent Counsel, M/S 2061
 Legal Affairs Dept.
 Applied Materials, Inc.
 P.O. Box 450-A
 Santa Clara, CA
 95035

TITLE
 Plasma immersion ion implantation process using a capacitively coupled plasma source having low dissociation and low minimum plasma voltage

<input type="checkbox"/> All Fees

FILING FEE RECEIVED 2106	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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